Gallium Phosphide IMPATT Sources for Millimeter-Wave Applications

A. Acharyya^a(C.A.)

Abstract: The potentiality of millimeter-wave (mm-wave) double-drift region (DDR) impact avalanche transit time (IMPATT) diodes based on a wide bandgap (WBG) semiconductor material, Gallium Phosphide (GaP) has been explored in this paper. A non-sinusoidal voltage excited (NSVE) large-signal simulation method has been used to study the DC and high frequency characteristics of DDR GaP IMPATTs designed to operate at mm-wave atmospheric window frequencies such as 94, 140 and 220 GHz. Results show that the DDR GaP IMPATTs are capable of delivering significantly higher RF power at the above mentioned window frequencies as compared to the DDR IMPATTs based on the conventional narrow bandgap (NBG) base materials such as Si, GaAs and InP.

Keywords: Gallium Phosphide, IMPATT Diode, Large-Signal, Millimeter-Wave.

1 Introduction

IMPACT avalanche transit time (IMPATT) diodes have emerged as the most efficient and convenient two terminal solid-state source for the generation of high RF power with DC to RF conversion efficiency at microwave (3 – 30 GHz) and mm-wave (30 – 300 GHz) frequencies [1-3]. Silicon (having bandgap of E_g = 1.12 eV at 300 K) is the most widely used semiconductor base material for the fabrication of IMPATT diodes due to its matured process technology [4-6]. However, some narrow bandgap (NBG) group III-V semiconductors such as GaAs (E_g = 1.43 eV at 300 K) and InP (E_g = 1.35 eV at 300 K) have also established themselves as powerful and efficient base materials of IMPATT diodes operating at different mm wave atmospheric window frequencies [7-11]. Recently, some researchers have explored the potentiality of a number of wide bandgap (WBG) semiconductors such as 4H-SiC (E_g = 3.23 eV at 300 K), 6H-SiC (E_g = 2.86 eV at 300 K), 3H-SiC (E_g = 2.36 eV at 300 K), Wz-GaN (E_g = 3.40 eV at 300 K) etc. as the base material of IMPATT diodes capable of delivering high RF power with significantly high DC to RF conversion efficiency at microwave, mm-wave and Terahertz (> 300 GHz) frequency regime [12-16].

In this paper, the authors have explored the potentiality of another WBG semiconductor, i.e. GaP (E_g = 2.26 eV at 300 K) as the base material of DDR IMPATT diodes operating and mm-wave window frequencies such as 94, 140 and 220 GHz. A well established non-sinusoidal voltage excitation (NSVE) model based large-signal simulation tool developed by the authors [17-21] has been used to carry out the DC and high frequency simulation of DDR GaP IMPATT diodes designed to operate at abovementioned frequencies. Finally, the large-signal performance of DDR GaP IMPATTs has been compared with that of DDR IMPATTs based on Si, GaAs and InP, in order to verify the superiority of GaP over those conventional base materials.

2 Design and Material Parameters

One-dimensional (1-D) model of the n^+–n–p–p^+ structured DDR IMPATT diode shown in Fig. 1 is taken into account in the present simulation. It may be assumed without any loss of generality or accuracy that the physical phenomena take place in the semiconductor bulk along the symmetry axis (i.e. x-axis) of the device during IMPATT operation under reverse bias. No
potential and density gradients are present along other two directions (i.e. along y- and z-axes) and therefore, carrier transport only takes place along x-axis. Thus the consideration of 1-D model is absolutely justified [22,23]. The realistic doping profile of the device is taken into account by incorporating appropriate exponential function near n-p metallurgical junction and appropriate error functions near n"-n and p"-p interfaces [24]. The design parameters such as widths of n- and p-epitaxial layers (i.e. \( W_n \) and \( W_p \)), corresponding doping concentrations (i.e. \( N_D \) and \( N_A \)) and optimum bias current density \( J_0 \) for IMPATT operation at a particular design frequency \( f_0 \) are chosen by using a organized trial and error method reported earlier by the authors [17]. The design parameters of 94, 140 and 220 GHz DDR GaP IMPATTs are given in Table 1.

![Fig. 1 One-dimensional (1-D) model of the n"-n-p-p" structured DDR IMPATT diode.](image)

Table 1 Design parameters.

<table>
<thead>
<tr>
<th>Design frequency, ( f_0 )</th>
<th>94.00 GHz</th>
<th>140.00 GHz</th>
<th>220.00 GHz</th>
</tr>
</thead>
<tbody>
<tr>
<td>Thickness of the n-epitaxial layer, ( W_n )</td>
<td>1.125 ( \mu )m</td>
<td>0.800 ( \mu )m</td>
<td>0.510 ( \mu )m</td>
</tr>
<tr>
<td>Thickness of the p-epitaxial layer, ( W_p )</td>
<td>1.125 ( \mu )m</td>
<td>0.800 ( \mu )m</td>
<td>0.510 ( \mu )m</td>
</tr>
<tr>
<td>Donor concentration of the n-epitaxial layer, ( N_D )</td>
<td>0.300 ( \times )10(^{23} ) m(^{-3} )</td>
<td>0.480 ( \times )10(^{23} ) m(^{-3} )</td>
<td>0.800 ( \times )10(^{23} ) m(^{-3} )</td>
</tr>
<tr>
<td>Acceptor concentration of the p-epitaxial layer, ( N_A )</td>
<td>0.400 ( \times )10(^{23} ) m(^{-3} )</td>
<td>0.680 ( \times )10(^{23} ) m(^{-3} )</td>
<td>1.150 ( \times )10(^{23} ) m(^{-3} )</td>
</tr>
<tr>
<td>Donor concentration of the p&quot;-contact layer, ( N_{D+n} )</td>
<td>0.500 ( \times )10(^{23} ) m(^{-3} )</td>
<td>0.500 ( \times )10(^{23} ) m(^{-3} )</td>
<td>0.680 ( \times )10(^{23} ) m(^{-3} )</td>
</tr>
<tr>
<td>Acceptor concentration of the p&quot;-contact layer, ( N_{A+n} )</td>
<td>0.700 ( \times )10(^{23} ) m(^{-3} )</td>
<td>0.700 ( \times )10(^{23} ) m(^{-3} )</td>
<td>0.700 ( \times )10(^{23} ) m(^{-3} )</td>
</tr>
<tr>
<td>Junction diameter, ( D_j )</td>
<td>35.00 ( \mu )m</td>
<td>25.00 ( \mu )m</td>
<td>20.00 ( \mu )m</td>
</tr>
<tr>
<td>Bias current density, ( J_0 )</td>
<td>2.50 ( \times )10(^8 ) A m(^{-2} )</td>
<td>5.10 ( \times )10(^8 ) A m(^{-2} )</td>
<td>9.40 ( \times )10(^8 ) A m(^{-2} )</td>
</tr>
</tbody>
</table>

field and current boundary conditions at depletion layer edges by using finite difference method (FDM) [17-21]. The simultaneous numerical solution of the abovementioned equations provides DC outcomes such as spatial variations of electric field, electric potential, electron and hole components of the current density, electron and hole concentrations, etc. within the depletion layer as well as breakdown voltage \( (V_B) \), avalanche voltage drop \( (V_A) \), avalanche region width \( (x_A) \), etc. as functions of bias current density.

In the next step, the time variation in the terminal voltage across the reverse biased diode is introduced by a non-sinusoidal RF waveform having form \( V_y(t) = V_R(m \sin(2\pi f_d t) + m_1 \sin(4\pi f_d t) + m_3 \sin(6\pi f_d t) + ... + m_m \sin(2m\pi f_d t)) \) with a fundamental frequency \( (f_d) \) term along with \( (z - 1) \) number of harmonics; where \( m \) is the percentage of modulation of the RF waveform over \( V_R \). The time variation \( V_y(t) \) introduces time variations in the aforementioned device equations. Therefore, by solving those time and space dependent device equations subject to appropriate time dependent field and current boundary conditions at depletion layer edges for different values of \( m \) ranging from 0 – 70%, the corresponding terminal current \( (i_y(t)) \) waveforms are obtained. The value \( m = 0.0 \) is corresponding to no time variation, i.e. DC simulation; whereas \( m > 0.0 \) values provide time varying solutions of \( i_y(t) \). On the other hand, time varying terminal voltage \( (v_y(t)) \) for each \( m \) values are obtained by integrating corresponding time and space dependent electric field \( (\xi(x,t)) \) with respect to \( x \) within the depletion layer (i.e. from \( x = -W_n \) to \( x = W_p \)). The value of \( m \) should not be increased beyond 70%, because over-modulation causes significant decrease in electric field during negative half cycles of the oscillation, which, in turn, degrades the field dependent material parameters in large extent and consequently causes deterioration in large-signal performance of the device. The device system is made time dependent by introducing non-sinusoidal
waveform \( v(t) \) at the starting point, that is why this method is called non-sinusoidal voltage excitation (NSVE) model for large-signal simulation. Now the time domain \( v(t) \) and \( i(t) \) are Fourier transformed in order to obtain the frequency domain \( v(f) \) and \( i(f) \). After that the diode admittance as function of frequency is obtained as 
\[
Y_d(f) = \frac{i(f)}{v(f)}
\]
Decomposing the real and imaginary parts of \( Y_d(f) = G(f) + j B(f) \), provides the knowledge of conductance \( G(f) \) and susceptance \( B(f) \) as functions of frequency. The frequency at which \( G(f) \) changes sign from positive to negative, is called avalanche resonance frequency \( f_a \). IMPATT operation starts when the frequency is increased above \( f_a \) and the device becomes capable of delivering RF power to the load. Ultimately, the RF power output \( P_{RF} = (1/2)(m_xV_B)^2|G_p|A_j \) and DC to RF conversion efficiency \( \eta = P_{RF}/P_{DC} \) (where \( P_{DC} = J_0V_BA_j \)) are obtained as the outcome of the large-signal program as functions of \( m_x \); where \(|G_p|\) is the peak magnitude of the negative conductance corresponding to the optimum frequency \( f_o \) of operation, \( A_j = \pi(D/2)^2 \) is the junction area \( (D) \) is the diameter of the junction having circular cross-section) [17-21]. The value of \( m_x \) is kept 5% during the first run of the large-signal program and it is increased by a step \( \Delta m_x = 5\% \) after each run of it. Finally the large-signal program is terminated when \( m_x \) reaches 70%. The complete flowchart of the simulation program is shown in Fig. 2.

![Flowchart of the simulation program.](https://example.com/flowchart.png)
4 Results and Discussion

The simulation method described above has been used to study the DC and large-signal properties of DDR GaP IMPATT diodes designed to operate at 94, 140 and 220 GHz frequencies. The simulations have been carried out for the bias current densities ranging from $2.0 \times 10^6$ – $3.0 \times 10^8$, $4.5 \times 10^8$ – $5.5 \times 10^8$ and $9.0 \times 10^8$ – $1.0 \times 10^9$ A m$^{-2}$ corresponding to 94, 140 and 220 GHz diodes. The range of the bias current density for a diode has been chosen for which the diode possesses negative conductance (i.e. the real part of the diode admittance $G(f)$ is negative); that means for any value of bias current density smaller or larger than the range provided here, the respective diode possesses positive conductance (i.e. real part of the diode impedance $G(f)$ is positive) which is corresponding to non-oscillating condition and it will not able to deliver RF power to the load.

4.1 DC Characteristics

The electric field profiles of the diodes at 94, 140 and 220 GHz frequencies corresponding to the optimum bias current densities of $2.5 \times 10^8$, $5.1 \times 10^8$ and $9.4 \times 10^8$ A m$^{-2}$ obtained from the DC simulation are shown in Fig. 3. It is observed that peak electric field increases significantly with the increase of operating frequency. It is obvious, since the thickness of the active region of IMPATT diode (i.e. $W = W_n + W_p$) decreases (see Table 1) in order to support higher frequency of operation; which leads to narrower depletion region width and larger peak electric field at the metallurgical junction in higher frequency diodes.

Variations of important DC parameters such as peak electric field ($\xi_p$), breakdown voltage ($V_B$), avalanche zone voltage drop ($V_\lambda$), ratio of drift zone voltage drop ($V_D = V_B - V_\lambda$) to breakdown voltage ($V_D/V_B$), avalanche region width ($x_A$) and ratio of avalanche zone width to total depletion region width ($x_A/W$), etc. of the diodes with bias current density ($J_0$) have been shown in Figs. 4 (a) – (i). It is observed from Figs. 4 (a) – (c) that $\xi_p$ decreases slightly from $7.1979 \times 10^7$ – $7.1493 \times 10^7$, $7.6532 \times 10^7$ – $7.6143 \times 10^7$ and $8.2306 \times 10^7$ – $8.1932 \times 10^7$ V m$^{-1}$ in 94, 140 and 220 GHz DDRs for increment of the $J_0$ from $2.0 \times 10^8$ – $3.0 \times 10^8$, $4.5 \times 10^8$ – $5.5 \times 10^8$ and $9.0 \times 10^8$ – $1.0 \times 10^9$ A m$^{-2}$ respectively. Due to the presence of higher amount of space charges in the depletion region of a reverse biased IMPATT diode at higher current densities, peak electric field at the $p-n$ junction decreases, however electric field at each space point within the depletion layer away from the junction slightly increases [31, 32]; even the diode may become highly punch through at higher bias current densities. Figures 4 (d) – (f) show the variations of $V_B$, $V_\lambda$ and $V_D/V_B$ of the diodes with $J_0$. Higher current through the device causes larger voltage drop across the depletion layer, which, in turn, increases the break down voltage ($V_B$). The value of $V_B$ increases from $85.90$ – $90.68$, $62.63$ – $65.11$ and $44.65$ – $44.99$ V in 94, 140 and 220 GHz diodes respectively for the increment of abovementioned ranges of $J_0$. The changes of $V_B$ and $V_D/V_B$ are observed to be $40.01$ – $43.92$, $30.88$ – $32.35$, $23.10$ – $24.36$ V and $53.42$ – $51.57$, $50.69$ – $51.31$, $48.26$ – $45.85$% respectively. The avalanche region or multiplication region of the device has to be expanded in order to accommodate increased amount of carrier multiplications due to increased bias current density. Therefore, the avalanche region width ($x_A$) has to be greater for greater bias current density. Variations of $x_A$ ($x_A = x_{ns} + x_{np}$; see Fig. 1) and $x_A/W$ of the diodes with bias current density are shown in Figs. 4 (g) – (i) which are clearly depicting the broadening of avalanche region with the increase of bias current density. Obviously, greater voltage drop occurs across the wider avalanche regions at higher bias current densities; as a result $V_B$ increases with the increase of $J_0$ as depicted earlier. The drift region width $V_B = V_B - V_\lambda$ decreases with the increase of $J_0$ since the rate of increase of $V_B$ with respect to $J_0$ is found to be slightly higher as compared to that of $V_B$; thus the ratio $V_B/V_B$ decreases with the increase of $J_0$. The ratio $V_B/V_B$ determines the DC to RF conversion efficiency of the diode as per the semi-quantitative formula reported earlier [33].

4.2 Large-Signal Characteristics

Variations of important large-signal parameters such as avalanche resonance frequency ($f_a$), optimum frequency ($f_o$), magnitude of the peak negative conductance ($|G_p|$), corresponding susceptance ($B_p$), quality factor or $Q$-factor ($Q_p = -B_p/G_p$) and peak magnitude of the negative resistance ($|Z_{dr}| = |G_p/(G_p^2 + B_p^2)|$) of the diodes for $m = 50\%$ with bias current
Fig. 4 Variations of static parameters of 94, 140 and 220 GHz DDR GaP IMPATT diodes with bias current density.

density have been shown in Figs. 5 (a) – (i). Sharp increase of $f_p$ is observed from 87.50 – 97.90, 135.20 – 142.10 and 214.70 – 225.70 GHz in 94, 140 and 220 GHz diodes for the increase of bias current density of $2.0 \times 10^8$ – $3.0 \times 10^8$, $4.5 \times 10^8$ – $5.5 \times 10^8$ and $9.0 \times 10^8$ – $10.0 \times 10^8$ A m$^{-2}$ respectively. However, the increase of $f_a$ is found to be 47.60 – 54.20, 77.10 – 83.40 and 113.70 – 123.00 GHz in those diodes with the same increase of $J_0$, which are less sharp as compared to $f_p$ versus $J_0$. Greater bias current causes greater amount of space charge effect [31, 32] and as a result the electric field at each space point away from the junction increases as mentioned earlier. Greater electric field at the majority portion of the depletion layer especially near the depletion layer edges increases carrier drift velocity (since near the depletion layer edges field value are not so high that the carrier drift velocity reaches its saturation value (see Fig. 3)), since unsaturated carrier drift velocities are monotonically increasing functions of electric field [28]; consequently, the carriers need less transit time to travel from one to another electrode, which leads to increase in both $f_p$ and $f_a$. Increment in bias current density causes increment in the admittance of the device; thus both the magnitudes of the negative conductance and susceptance must increase with the increase of bias current density. Figures 5 (d) – (f) show that both $|G_p|$ and $B_p$ increase with the increase of $J_0$.

Admittance characteristics of 94, 140 and 220 GHz diodes for the optimum bias current densities of $2.5 \times 10^8$, $5.1 \times 10^8$ and $9.4 \times 10^8$ A m$^{-2}$ have been shown in Fig. 6. Optimum values of $G_p$ and $B_p$ are found to be $-0.1315 \times 10^7$, $-0.3019 \times 10^7$, $-0.6439 \times 10^7$ S m$^{-2}$ and $0.5573 \times 10^7$, $1.1504 \times 10^7$, $2.8326 \times 10^7$ S m$^{-2}$ respectively corresponding to the abovementioned optimum bias current densities. Moreover, the optimum values of $f_a$ and $f_p$ are found to be 51.90, 82.10, 119.60 GHz and 93.60, 140.10, 220.40 GHz respectively. The $Q$-factor of the diodes remains around 4.0 for all bias current densities under consideration. On the other hand, it is noteworthy from Figs. 5 (g) – (i) that $|Z_R|$ increases with the increase of bias current density which indicates the increase of RF power output with the increment of $J_0$. However, $|Z_R|$ decreases sharply with the increase of operating frequency of the device; this fact is the cause...
Fig. 5 Variations of large-signal parameters of 94, 140 and 220 GHz DDR GaP IMPATT diodes with bias current density.

Fig. 6 Admittance characteristics of 94, 140 and 220 GHz DDR GaP IMPATT diodes for the bias current densities of $2.5 \times 10^8$, $5.1 \times 10^8$ and $9.4 \times 10^8$ A m$^{-2}$ respectively.
of sharp decay of RF power output at higher mm-wave frequencies.

The variations of $P_{RF}$ and $\eta_L$ of 94, 140 and 220 GHz diodes with bias current density are shown in Figs. 7 (a) and (b) respectively. Monotonically increasing $P_{RF}$ with $J_0$ is observed for all the diodes under consideration; it is obvious, since both $V_B$ and $|G_p|$ are monotonically increasing functions of $J_0$ which have been already illustrated in Figs. 4 (d) – (f) and 5 (d) – (f). However, variations of $\eta_L$ with $J_0$ are found to be (a) initially increasing up to 6.09% for $2.20 \times 10^8$ A m$^{-2}$, after which monotonically decreasing till $3.00 \times 10^8$ A m$^{-2}$ in 94 GHz diode, (b) initially decreasing up to 4.69% for $5.20 \times 10^8$ A m$^{-2}$, after which monotonically increasing till $5.50 \times 10^8$ A m$^{-2}$ in 140 GHz diode and (c) initially decreasing up to 3.80% for $9.70 \times 10^8$ A m$^{-2}$, after which monotonically increasing till $10.00 \times 10^8$ A m$^{-2}$ in 220 GHz diode.

Since now, all the large-signal parameters presented in this paper are for $m_x = 50\%$. Simulations have also been carried out by varying the $m_x$ from 5.0 – 70.0% in order to study the variations of large-signal parameters with RF voltage ($V_{RF} = m_x V_B$). Variations of $P_{RF}$ and $\eta_L$ of the DDR GaP IMPATTs with $V_{RF}$ for the corresponding optimum bias current densities have been shown in Figs. 7 (c) and (d). It is interesting to observe from Fig. 7 (c) that $P_{RF}$ initially increases with the increase of $V_{RF}$ and attains its peak when $m_x$ reaches 60%. Then $P_{RF}$ decreases sharply with further increase of $m_x$ beyond 60%. The nature of $\eta_L$ vs. $V_{RF}$ also shows the same nature. The degradation of $P_{RF}$ and $\eta_L$ at voltage modulation factors larger than 60% occurs due to the deterioration of field dependent material parameters at very low electric fields during negative half cycles of the RF voltage swing. Therefore, the value of the voltage modulation factor must be within 50 – 60% in order to obtain highest RF power output from the device with maximum DC to RF conversion efficiency.

4.3 Comparison with IMPATT Sources Based on Si, GaAs and InP

Variations of RF power output of IMPATT sources based on GaP as well as some conventional base materials such as Si, GaAs and InP with operating frequency have been shown in Fig. 8. It is interesting to observe from Fig. 8 that DDR GaP IMPATT diodes are capable of delivering much higher RF power (1.23 W, 757.34 mW and 505.43 mW) as compared to their Si (653.35, 378.89 and 297.50 mW) [19] and GaAs (781.37, 227.02 and 177.77 mW) [34] counterparts at 94, 140 and 220 GHz window frequencies respectively. DDR InP IMPATT diode delivers slightly higher RF power (1.33 W) at 94 GHz as compared to DDR GaP IMPATT operating at that frequency [34]. However, DDR GaP IMPATTs excel its InP counterparts (719.97 and 440.93 mW) at higher mm-wave frequencies, i.e. at 140 and 220 GHz respectively [34]. Therefore, GaP is the more preferable material over conventional base materials such as Si, GaAs and InP for fabricating DDR IMPATTs, especially at higher mm-wave frequencies (>100 GHz).

![Fig. 7 Variations of RF power output and DC to RF conversion efficiency of 94, 140 and 220 GHz DDR GaP IMPATT diodes with (a), (b) bias current density and (c), (d) RF voltage respectively.](image-url)
4.4 Validation of the Simulation Results

Experimentally obtained RF power outputs from DDR IMPATTs sources based on Si, GaAs and InP have been shown in Fig. 8. Experimental RF power outputs from DDR Si IMPATT oscillators are 600, 300 and 50 mW at 94, 140 and 220 GHz respectively [1,4,6]. Experimental RF power output from DDR GaAs IMPATTs are 270 and 100 mW at 95 and 144 GHz respectively [7,10] and same from DDR InP IMPATT source is 55 mW at 84.8 GHz [11]. It is noteworthy from Fig. 8 that the NSVE large-signal simulation results are in close agreement with experimental results in most of the cases. Discrepancy observed in between simulation experimental results in case of 220 GHz Si DDR and DDWs based on GaAs and InP are due to lack of matured process technology and un-optimized design parameters used for fabrication of those diode for those experiments [1,4,6,7,10,11]. So far as authors’ knowledge is concerned, no experimental report on the RF performance of DDR GaP IMPATTs is available in published literature and so the comparison with simulation results cannot be made.

5 Conclusion

The potentiality of mm-wave DDR IMPATTs based on GaP have been explored in this paper. Comprehensive DC and large-signal simulations have been carried out on DDR GaP IMPATT diodes design to operate at 94, 140 and 220 GHz mm-wave window frequencies for this purpose and results have presented in the forms of necessary graphs or plots. Results show that the DDR GaP IMPATTs are capable of delivering considerably higher RF power at mm-wave atmospheric window frequencies as compared to their conventional counterparts such as DDR IMPATTs based on Si, GaAs and InP. Optimum design parameters and simulation results presented in this paper will be useful for fabricating mm-wave DDR GaP IMPATT diodes by using either molecular beam epitaxy (MBE) or metalorganic chemical vapour deposition (MOCVD) technique.

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References


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